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INFORMATION DISCLOSURE					amed Inventor	Gau, Vincent Jen-Jr						
STATEMENT BY APPLICANT Group					Art Unit	1639						
(use as many sheets necessary)				Exami	ner Name	My-Chau T. Tran						
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Remer et al. Surface Stress in the Self-Assembly of Alkanethiols in Gold Probed by a Force Microscopy Technique, Apol, Phys. A 66, S5								Appl. Phys. A 66, S55-S59				
MCT	1	(1998).										
	2	Dubois et al., Synthesis, Structure, and Properties of Model Organic Surfaces, Annu. Rev. Phys. Chem. 1992, 43:437-63.										
	3	Knobler et al., Phase Transitions in Monolayers, Annu. Rev. Phys. Chem. 1992, 25:207-36.										
	4	Kokkoli et al 60-65 (1999	Kokkoli et al., Effects of Solvents on Interactions Between Hydrophobic Self-Assembled Monolayers, Journal of Colloid and Interface Sciences 209,									
	5	Lyons, Mich	ael E.G., Med	fiated Electron	Transfer at Redox Ac	tive Monolayers,	Sensors 20	001, 1, 215-228.				
	6	Lyons, Mich	Lyons, Michael E.G., Mediated Electron Transfer at Redox Active Monolayers. Part 2:Analysis of the Chromoamperometric response to Potential Step Perturbation, Sensors 2002, 2, 314-330.									
		Lyons, Michael E.G., Mediated Electron Transfer at Redox Active Monoleyers. Part 3: Biomolecular Outer-Sphere, First Order Koutecky-Levich and										
	7	Adduct Formation Mechansims, Sensors 2002, 2, 473-506.										
	8	Lyons, Michael E.G., Mediated Electron Transfer at Redox Active Monolayers. Part 4: Kinetics of Redox Enzymes Coupled with Electron Mediators, Sensors 2003, 3, 19-42.										
	9	Mrksich et al., Using Self-Assembled Monolayers to Understand the Interactions of Man-Made Surfaces with Proteins and Cells, Annu. Rev. Biophys. Biomol. Struct. 1996, 25:55-78.										
	10	Rau et al., Measurement of the Repulsive Force Between Polyelectrolyte Molecules in Ionic Solution: Hydration Forces Between Parallel DNA Double Helices, Proc. Natl. Acad. Sci. USA, Vol. 81, pp 2621-2625, May 1984, Biochemistry.										
	11	Schreiber, Frank, Self-Assembled Monolayers: From 'Simple' Model Systems to Biofunctionalized Interfaces, J. Phys.: Condens. Matter 16 (2004) R881-R900.										
-₩	12	Schwartz, Daniel K., Mechansims and Kinetics of Self-Assembled Monolayer Formation, Annu. Rev. Phys. Chem. 2001, 52:107-37.										
MCT	Value and all Developing Soft Assembly and Directed Assembly of DNA Lined Micromater Sized College PNAS March 22 2005 vol 102 po											
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